



Commissioner for Patents
Washington, DC 20231
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9732

SERIAL NUMBER 10/089,176	FILING DATE 08/20/2002 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. 0456636-5057	
APPLICANTS Jacques Baudon, Paris, FRANCE; Jacques Robert, Paris, FRANCE; ** CONTINUING DATA ***** This application is a 371 of PCT/FR00/02664 09/27/2000 ** FOREIGN APPLICATIONS ***** FRANCE 99/12016 09/27/1999					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY FRANCE	SHEETS DRAWING	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 1
ADDRESS 09629					
TITLE Method and device for atomic interferometry nanolithography					
FILING FEE RECEIVED 1020	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		